CLAIMS

- 1. A gallium nitride-based semiconductor device having a p-type layer that is a gallium nitride (GaN) compound semiconductor layer containing a p-type impurity and exhibiting p-type conduction, wherein the p-type layer comprises a top portion and an inner portion located under the top portion, wherein the inner portion contains the p-type impurity and, in combination therewith, hydrogen and wherein the top portion includes a region containing a Group III element and a Group V element at a non-stoichiometric atomic ratio.
- 2. A gallium nitride-based semiconductor device according to claim 1, wherein the inner portion of the p-type layer has a percent thickness of 40% to 99.9% with respect to a thickness of the p-type layer.
- 3. A gallium nitride-based semiconductor device according to claim 1 or claim 2, wherein the inner portion of the ptype layer has a hydrogen concentration of 1×10^{18} cm⁻³ or more and an impurity concentration of 1×10^{18} cm⁻³ to 1×10^{21} cm⁻³.
- 4. A gallium nitride-based semiconductor device according to any one of claims 1 to 3, wherein the inner portion has a hydrogen concentration that is equal to, or lower than, an impurity concentration.

- 5. A gallium nitride-based semiconductor device according to any one of claims 1 to 4, wherein the region containing a Group III element and a Group V element at a non-stoichiometric atomic ratio has a thickness of 1 to 10 nm from the top surface of the p-type layer in a depth direction.
- 6. A gallium nitride-based semiconductor device according to any one of claims 1 to 5, wherein the top portion of the p-type layer has a surface having Ga deposited thereon.
- 7. A gallium nitride-based semiconductor device according to any one of claims 1 to 6, wherein the p-type layer has a surface having joined thereto a gallium nitride semiconductor material containing a Group III element and a Group V element at a non-stoichiometric atomic ratio.
- 8. A gallium nitride-based semiconductor device according to claim 7, wherein the gallium nitride semiconductor material is boron phosphide (BP) having a non-stoichiometric atomic ratio.